

**PATENT APPLICATION**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of

Docket No: Q84448

Michel PUECH

Appln. No.: 10/516,457

Group Art Unit: 1763

Confirmation No.: 2874

Examiner: unknown

Filed: December 3, 2004

For: HEATER LINER FOR A PLASMA ETCHING REACTOR, AND AN ETCHING  
METHOD USING THE LINER

**AMENDMENT UNDER 37 C.F.R. § 1.111**

**MAIL STOP AMENDMENT**

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated April 5, 2007, please amend the above-identified application as follows on the accompanying pages.